

Notice of References Cited

Application/Control No.

10/526,896

Applicant(s)/Patent Under
Reexamination
HASEGAWA ET AL.

Examiner

Aaron S. Austin

Art Unit

1775

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	As provided by the USPTO Translations Branch: English Translation of Preparation of SmBaCu302 Films with Improved In-Plane Alignment by Pulsed Laser Deposition; J. Japan Inst. Metals. Vol. 66, No. 4 (2002) pp 320-328.
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